

# Embedded optical solutions through X-FAB's Foundry offering

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#### Who we are





- We are a specialty foundry offering a unique combination of analog/mixed-signal, high-voltage and embedded non-volatile memory options with sensor and actuator integration.
- > We support **long product lifecycles of 20+ years** and focus on automotive, industrial and medical end markets.
- We provide best-in-class design and prototyping support to enable first-time-right design.
- > All of our sites are **automotive certified**.



#### CMOS & SOI offering with MEMS integration





Large portfolio of process technologies & IP

Features \* in development, start of production in 2023

M/S = mixed-signal, NVM = non-volatile memory, RF = radio frequency, SOI = silicon on insulator, MEMS = microelectromechanical systems, SiC = silicon carbide

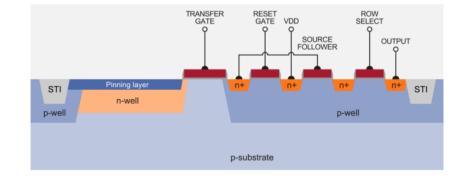
Modular combination of digital, analog, high-voltage, non-volatile memories and sensors

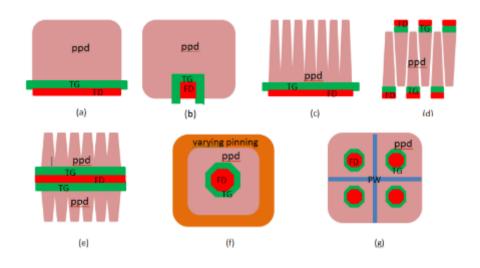


#### XS018 CMOS Imaging Sensors technology



- > X-FAB offer for X-Ray is an 180nm image sensor process with special support for large pixel
  - XS018 is a dedicated Image Sensor Platform qualified to AEC-Q100 standard
  - > Modular process platform enabling cost effective products
  - Various module settings to optimize pinning voltage of the photodiode and threshold voltage of transistors
  - > Different reference layouts for high dynamic range, low dark current, optimized fill factor and low image lag
  - Support of large image sensors by one- or two-dimensional stitching
  - > Ultra low noise transistors, high conversion gain pixels, and global shutter pixels are in development.
  - > Working with a 3<sup>rd</sup> party supplier for BSI capability

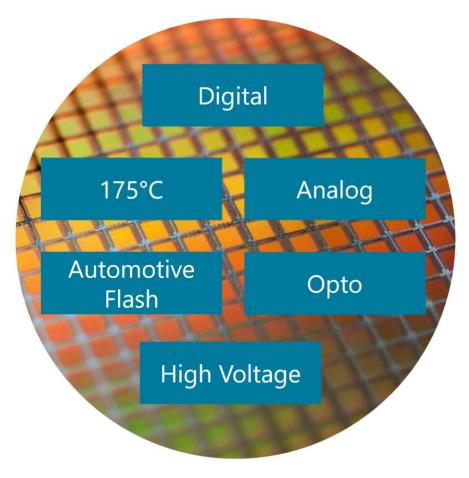




#### XH018 - UV Photodiodes



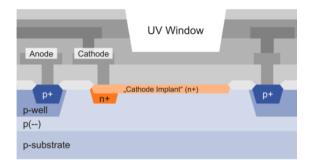
### XH018 - 180 nm automotive CMOS technology platform for high-voltage and sensor applications

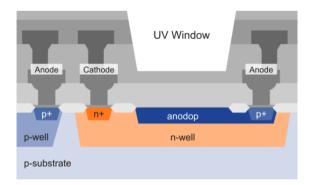


#### Embedded UV photodiodes

- > UV-window to improve sensitivity
- PDs with highly doped
  n-implant as cathode and
  a special ANODOP layer
  for a high-sensitive anode
- Optional poly layer on top of PD to cut UV and blue light

and blind metal covered PD as reference device

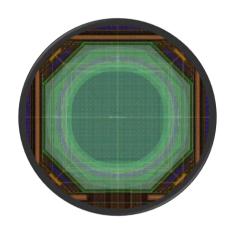


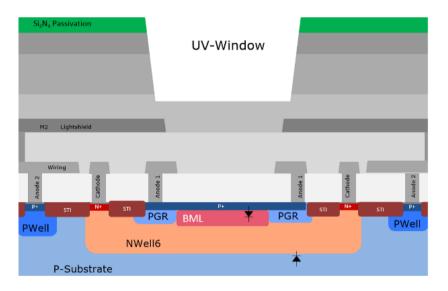


#### XH018 – APD/SPAD

- > High sensitivity and PDP from UV up to NIR
- Primitive device for visible and infrared light detection in avalanche operation mode
- > Special Application note helps to integrate APD/SPAD
- > Optical and electrical models available for IC simulation
- > XH018 evaluation chips and application evaluation kit available
- > 1 additional photo mask









## Thank you.



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